

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Application of: **FURUYA, Akira et al.**

Serial No.: **10/026,451**

Filed: **December 27, 2001**

Group Art Unit: 2815

Examiner: **Bradley w. Baumeister**

P.T.O. Confirmation No.: 1605

For: **SEMICONDUCTOR PHOTO DETECTING DEVICE AND ITS
MANUFACTURING METHOD**

RESPONSE TO THE RESTRICTION REQUIREMENT
DATED January 22, 2003

Commissioner for Patents
Washington, D.C. 20231

Date: **February 21, 2003**

Sir:

This paper is submitted in response to the Official Action dated January 22, 2003.

In the Action, restriction is required between **Group (I)**, Claims 1-10; and **Group (II)**, Claim 11.

Applicants hereby elect the subject matter of **Group (I)**, **Claims 1-10** for prosecution in this application. This election is made without traverse, it being understood that the applicants' rights to the filing of a divisional application directed to the non-elected subject matter under 35 USC 120 and 35 USC 121 are retained.

In the event that this paper is not timely filed, applicants hereby petition for an appropriate extension of time. The fee for any such extension may be charged to our Deposit Account No. 01-2340.

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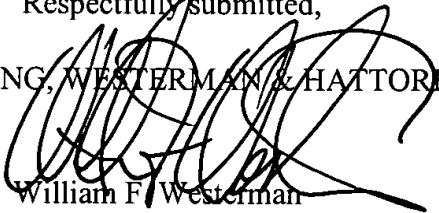
By: Akira FURUYA et al.

Serial No. 10/026,451

In the event any additional fees are required in connection with this response, please
charge our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP


William F. Westerman
Attorney for Applicants
Reg. No. 29,988

WFW/meu

Atty. Docket No. **011758**
Suite 1000, 1725 K Street, N.W.
Washington, D.C. 20006
(202) 659-2930



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